

**PSG INSTITUTE OF ADVANCED STUDIES, COIMBATORE
NANOTECH RESEARCH FACILITY**

**JOB REQUISITION FORM FOR MULTISOURCE PHYSICAL VAPOUR DEPOSITION
SYSTEM WITH GLOVE BOX**

Name:		Designation:
Address: (Institution/Department)		Contact number:
		Email ID:
Supervisor:		Contact number:
		Email ID:
Internal (PSG)/External/Industry		
Number of depositions		
Is Co-deposition required? (tick any one)		: YES/NO

PVD Source	Description of Material to be deposited	Description of Substrate material	Desired film thickness	Co-sputtering/Co-evaporation required, if yes mention the different materials
Thermal Evaporation				
Electron beam evaporation				
RF Magnetron Sputtering				
DC Magnetron Sputtering				
RADAK				

This work is part of the research activity of the department / center. No remuneration or compensation is received from any agency. Further, it is certified that the sample(s) do not pose a health risk to anybody.

Date:

Signature of Researcher

Recommendation of Supervisor :

Signature of the Head of the Dept/Institution:

For laboratory use:	
Job priority: high/medium/low Ref no: PSGIAS/cleanroomPVD/2014/	Date and time allotted:
Job completed on date:	Remarks:
Signature of faculty in-charge	
Approval	
Director, PSGIAS	

For office use

Ref. No:

Date:

Name and institution of the user				
Deposition (Technique)				
Deposition charges				
Payment details	DD/Cheque no.	Date	Bank name	Amount
Name of the faculty who conducted the experiment				